



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: P. Loges, et al.
Serial No: 10/074,188
Filing Date: February 12, 2002
Title: **FILAMENT FOR RADIATION SOURCE**
Examiner: Fastovsky, Leonid M.
Art Unit: 3742
Docket No: IOPL-119 (91968-010900)

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the U.S. Postal Service as first class mail in an envelope addressed to: Commissioner for Patents, P. O. Box 1450, Alexandria, VA 22313-1450 on the date indicated below.

Date: May 1, 2005

Ben Joplin
Ben Joplin

MS: Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

RESPONSE TO OFFICE ACTION

Sir:

In response to the Office Action mailed November 3, 2005, please amend the above-identified application as follows:

A listing of claims begins on page 2 of this paper.

Remarks/Arguments begin on page 7 of this paper.